



02-14-05

AF/IFW

EXPRESS MAIL NO.: EV 346 812 600 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Christophe MALEVILLE et al.

Confirmation no. 9223

Application No.: 10/754,930

Group Art Unit: 2825

Filing Date: January 8, 2004

Examiner: Calvin LEE

For: METHOD FOR PREPARING A
SEMICONDUCTOR WAFER SURFACE

Attorney Docket No.: 4717-8400

AMENDMENT

BOX AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This communication is responsive to the Office Action dated December 14,
2004.

Claim amendments begin on page 2 of this paper.

Remarks begin on page 5 of this paper.

No fee is believed to be due for this response, but if any fees are due, please
charge them to **Winston & Strawn LLP** Deposit Account No. 50-1814.